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Certificate of Publication

Ref: IJSRST/Certificate/Volume 3/Issue 1/754 19-Jan-2017

This is to certify that S. Abdullahi, M. Momoh, A. U. Moreh, A. M. Bayawa, B. Hamza, G. M. Argungu, O. T. Popoola have published a research paper entitled 'Growth Mechanism and influence of annealing temperature on structural and compositional properties of Cu²ZnSnS⁴ (CZTS) thin films deposited by RF sputtering method from a compound target.' in the International Journal of Scientific Research in Science and Technology (IJSRST), Volume 3, Issue 1, January-February-2017.

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